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	Application Number		10595434	
	Filing Date		2006-04-19	
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	1	Yau S T et al: "Laser-Assisted Deposition of Nanometer Structures Using A Scanning Tunneling Microscope" Applied Physics Letters, American Institute of Physics, New York, US, vol. 57, no. 27, 31 December 1990, pages 2913-2915 XP000222958 ISSN: 0003-6951 the whole document						
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